	Application Number		10577916	
INCORMATION DISCLOSURE	Filing Date		2006-05-01	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT	First Named Inventor Ryoji		FUNAHASHI	
(Not for submission under 37 CFR 1.99)	Art Unit			
(,	Examiner Name Not y		yet assigned	
	Attorney Docket Number	er	062440	

U.S.PATENTS							Remove				
Examiner Initial*	Cite No	Patent Number	Kind Code <sup>1</sup>	Issue D	Date	of cited Document			,Columns,Lines where ant Passages or Relevant s Appear		
	1										
If you wis	h to a	⊥ dd additional U.S. Patei	⊥ nt citatio	ı n inform	ation pl	l ease click the	Add button.		Add		
			U.S.P	ATENT	APPLI	CATION PUB	LICATIONS		Remove		
Examiner Initial*	Cite No	Publication Number	Kind Publication Code <sup>1</sup> Date			of cited Document		es,Columns,Lines where vant Passages or Relevan res Appear			
	1										
If you wis	h to a	dd additional U.S. Publi	shed Ap	plication	citatio	n information p	olease click the Ad	d buttor	. Add		
				FOREIG	GN PAT	ENT DOCUM	IENTS		Remove		
Examiner Initial*	Cite No	Foreign Document Number <sup>3</sup>	Country Code <sup>2</sup>		Kind Code <sup>4</sup>	Publication Date	Name of Patente Applicant of cited Document	e or	Pages,Colui where Relev Passages oi Figures App	/ant r Relevant	T5
/X.T./	1	64-079019	JP		А	1989-03-24	DAINICHISEIKA COLOR & CHME I CO LTD	MFG			<b>\</b>
/X.T./	2	06-329463	JP		А	1994-11-29	HITACHI METALS	LTD			<b>V</b>
/X.T./	3	11-242960	JP		А	1999-09-07	NTT				V
					<u> </u>						

## INFORMATION DISCLOSURE STATEMENT BY APPLICANT

( Not for submission under 37 CFR 1.99)

Application Number		10577916		
Filing Date		2006-05-01		
First Named Inventor	Ryoji	Ryoji FUNAHASHI		
Art Unit				
Examiner Name	Not yet assigned			
Attorney Docket Number		062440		

/X.T./	4	2003-282964	JP	А	2003-10-03	NATIONAL INSTITUTE OF ADVANCED INDUSTRIAL & TECH		<b>V</b>
/X.T./	5	3472814	JP	B2	2003-09-19	NATIONAL INSTITUTE OF ADVANCED INDUSTRIAL & TECH		<b>V</b>
/X.T./	6	3069701	JP	B1	2001-03-13	AGENCY OF IND SCIENCE & TECHNOL		<b>V</b>
/X.T./	7	2001-223393	JP	А	2001-08-17	NATL INST OF ADVANCED INDUSTRIAL SCIENCE & TECH		<b>V</b>
/X.T./	8	3089301	JP	B1	2000-07-21	AGENCY OF IND SCIENCE & TECHNOL		
/X.T./	9	03000605	wo	A1	2003-01-03	NATL INST OF ADVANCED INDUSTRIAL SCIENCE & TECH		<b>✓</b>
If you wis	h to ac	dd additional Foreign P	atent Document	citation	information p	lease click the Add button	Add	
			NON-PATE	NT LITE	RATURE DO	CUMENTS	Remove	
Examiner Initials*	Examiner Initials*  Cite No  Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc), date, pages(s), volume-issue number(s), publisher, city and/or country where published.							
/X.T./	1	R. Chiba et al. "Properties of La1-ySryNi-xFexO3 as a cathode material for a low-temperature operating SOFC", Solid State Ionics, Vol. 152-153, pages 575 to 582 (2002)						
/X.T./	2	E. Rodriguesz,et al. "Structual Electronic and Magnetic Characterization of the Perovskite LaNi1-xO3", Journal of Materials Chemistry, Vol.148, pages 479 to 486 (1999)						
/X.T./	3	P. Odier et al., "Sol-gel synthesis and structural characterization of the perovskite type pseudo solid solutino LaNi0.5Cu0.5O3", Journal of Materials Chemistry, Vol.12, pages 1370 to 1373 (2000)						

## INFORMATION DISCLOSURE STATEMENT BY APPLICANT

( Not for submission under 37 CFR 1.99)

Application Number		10577916		
Filing Date		2006-05-01		
First Named Inventor	Ryoji	Ryoji FUNAHASHI		
Art Unit	•			
Examiner Name	Not yet assigned			
Attorney Docket Number		062440		

/X.T./	4	R. Funahashi et al., "Thermoelectric properties of Ln-Ni-O (Ln : lanthanoid) system", 22nd International Conference on Thermoelectric, pages 184 to 187 (2003)						
/X.T./	5	R. Funahashi et al, "Exploration of n-type oxides by high throughput screening", Applied Surface Science, Vol.223, pages 44 to 48 (2004)						
/X.T./	6	R. Furuhashi et al., "High-throughput screening of thermoelectric oxides and power generation modules consisting of oxide unicouples", Measurement Science and Technology, Vol.15, pages 1 to 11 (2004)						
/X.T./	7	English translation of International Search Report mailed on February 8, 2005 for International Application of PCT/ JP2004/015921						
If you wish to add additional non-patent literature document citation information please click the Add button Add								
EXAMINER SIGNATURE								
Examiner	aminer Signature /Xiuyu Tai/		Date Considered	04/09/2008				
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through a citation if not in conformance and not considered. Include copy of this form with next communication to applicant.								
<sup>1</sup> See Kind Codes of USPTO Patent Documents at <u>www.USPTO.GOV</u> or MPEP 901.04. <sup>2</sup> Enter office that issued the document, by the two-letter code (WIPO Standard ST.3). <sup>3</sup> For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. <sup>4</sup> Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. <sup>5</sup> Applicant is to place a check mark here if English language translation is attached.								